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Substitute for form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(Use as many sheets as necessary)</i>				Complete if Known	
				Application Number	To Be Assigned
				Filing Date	Concurrent Herewith
				First Named Inventor	COSTA, Lorenzo et al.
				Art Unit	To Be Assigned
				Examiner Name	To Be Assigned
				Attorney Docket Number	033965.0021
Sheet	1	of	2		

[illegible][illegible]

Examiner Signature		Date Considered	
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.¹ Applicant's unique citation designation number (optional).² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04.³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3).⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document.⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible.⁶ Applicant is to place a check mark here if English language Translation is attached.

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Substitute for form 1449B/PTO

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

(Use as many sheets as necessary)

Sheet 2 of 2

Completion if Known

Application Number	To Be Assigned
Filing Date	Concurrent Herewith
First Named Inventor	COSTA, Lorenzo et al.
Art Unit	To Be Assigned
Examiner Name	To Be Assigned
Attorney Docket Number	033965.0021

NON PATENT LITERATURE DOCUMENTS

Examiner Initials *	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
		MAEDA, Y., "Preparation of Nanometer-Size Crystalline Ge by Chemical Sol-Gel Method and Its Visible Photoluminescence," Japanese Journal of Applied Physics, 1994, pps. 254-256, vol. 34, no. 34-1, suppl. XP000527446, ISSN: 0021-4922, Publication Office Japanese Journal of Applied Physics, Tokyo, Japan (3 pages)	
		GARCIA, M. A. ET AL., "Characteristic UV luminescence from sol-gel silica coatings," Materials Letters, March 2000, pps. 23-26, vol. 43, no. 1-2, XP004256374, ISSN: 0167-577X, North Holland Publishing Company, Amsterdam, NL (4 pages)	
		FUJITA, S. ET AL., "Visible light-emitting devices with Schottky contacts on an ultrathin amorphous silicon layer containing silicon nanocrystals," Applied Physics Letters, January 11, 1999, pps. 308-310, vol. 74, no. 2, XP000804879, ISSN: 0003-6951, American Institute of Physics, New York, US (3 pages)	
		MUTTI, P. ET AL., "Room-temperature visible luminescence from silicon nanocrystals in silicon implanted SiO ₂ layers," Applied Physics Letters, February 13, 1995, vol. 66, no. 7, pps. 851-853, XP000489875, ISSN: 0003-6951, American Institute of Physics, New York, US (3 pages)	

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